

YOUNGJIN KIM

Postdoctoral Researcher
Stanford University, United States

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EDUCATION

Ph.D.	Electrical and Computer Engineering Seoul National University, South Korea Advisor: Byoungho Lee (deceased) Yoonchan Jeong	2019 – 2024
B.S.	Electrical and Computer Engineering Seoul National University, South Korea Advisor: Byung Gook Park (deceased)	2012 – 2019

CAREER

Postdoc	Stanford University , CA, USA Advisor: Mark Brongersma	2025 –
Postdoc	Seoul National University , South Korea Advisor: Yoonchan Jeong	2025
Internship	Meta Reality Labs , WA, USA Department: Optics, Photonics, and Light Systems (OPALS) Research Research subject: Development of new waveguide architecture	2024

HONOR AND AWARDS

- **Doyeon Academic Paper Award**
Inter-university Semiconductor Research Center, Seoul National University, 2025
- **Sejong Science Fellowship (Overseas Training Track)**
National Research Foundation of Korea, 2025.
- **Distinguished Dissertation Award**
Seoul National University, 2025.
- **Seoul National University Joint International Research Grant**
Seoul National University, 2023.
- **Silver Prize, Samsung Display Industry-Academia Technical Paper Awards**
Samsung Display, 2023.
- **Scholarship of Foundation for SNU ECE - Kim Jung Sik Fund**
Seoul National University, 2021.
- **Best Poster Paper Awards**
Optics and Photonics Congress, Jeju, South Korea, 2021.

JOURNAL PUBLICATIONS

First Author (4)

† : equal contribution

1. Y. Kim[†], T. Choi[†], G.-Y. Lee, C. Kim, J. Bang, J. Jang, Y. Jeong, and B. Lee, “Metasurface Folded Lens System for Ultrathin Cameras,” **Science Advances**, vol. 10, no. 44, pp. eadr2319, 2024.
2. Y. Kim, G.-Y. Lee, J. Sung, J. Jang, and B. Lee, “Spiral Metalens for Phase Contrast Imaging,” **Advanced Functional Materials**, vol. 32, no. 5, pp. 2106050, 2022.
3. S.-W. Nam[†], Y. Kim[†], D. Kim, and Y. Jeong, “Depolarized Holography with Polarization-multiplexing Metasurface,” **ACM Transactions on Graphics (SIGGRAPH Asia)**, vol. 42, no. 6, article 200, 2023.
4. Y. Park[†], Y. Kim[†], C. Kim, G.-Y. Lee, H. Choi, T. Choi, Y. Jeong, and B. Lee, “End-to-end Optimization of Metalens for Broadband and Wide-angle Imaging,” **Advanced Optical Materials**, vol. 13, no. 9, pp. 2402853, 2025.

Co-Author (8)

1. G.-Y. Lee[†], C. Kim[†], M. Gopakumar, Y. Kim, B. Lee, Y. Jeong, and G. Wetzstein, “Neural phase microscopy with metasurface optics for real-time and nanoscale quantitative phase imaging,” **Nature Communications**, 2025 (Accepted).
2. J. Bang, Y. Kim, T. Choi, C. Kim, H. Son, S.-J. Kim, Y. Jeong, and B. Lee, “Cascaded Janus meta-optics: generalized platform for bidirectional asymmetric modulation of light,” **ACS Photonics**, vol. 12, no. 3, pp. 1666-1675, 2025.
3. C. Kim, J. Hong, J. Jang, G.-Y. Lee, Y. Kim, Y. Jeong, and B. Lee, “Freeform Metasurface Color Router for Deep Sub-micron Pixel Image Sensors,” **Science Advances**, vol. 10, no. 22, pp. eadn9000, 2024.
4. T. Choi, C. Choi, J. Bang, Y. Kim, H. Son, C. Kim, J. Jang, Y. Jeong, and B. Lee, “Multiwavelength Achromatic Deflector in the Visible Using a Single-Layer Freeform Metasurface,” **Nano Letters**, vol. 24, no. 35, pp. 10980-10986, 2024.
5. H. Son, T. Choi, K. Kim, Y. Kim, J. Bang, S.-J. Kim, B. Lee, and Y. Jeong, “Strong Coupling Induced Bound States in the Continuum in a Hybrid Metal–Dielectric Bilayer Nanograting Resonator,” **ACS Photonics**, vol. 11, no. 8, pp. 3221-3232, 2024.
6. E. Lee, Y. Jo, S.-W. Nam, M. Chae, C. Chun, Y. Kim, Y. Jeong, and B. Lee, “Speckle Reduced Holographic Display System with a Jointly Optimized Rotating Phase Mask,” **Optics Letters**, vol. 49, no. 19, pp. 5659-5662, 2024.
7. J. Jang, G.-Y. Lee, Y. Kim, C. Kim, Y. Jeong, and B. Lee, “Dispersion-Engineered Metasurface Doublet Design for Broadband and Wide-Angle Operation in the Visible Range,” **IEEE Photonics Journal**, vol. 15, no. 4, pp. 1-9, 2023.
8. S.-J. Kim, C. Kim, Y. Kim, J. Jeong, S. Choi, W. Han, J. Kim, and B. Lee, “Dielectric metalens: properties and three-dimensional imaging applications,” **Sensors**, vol. 21, no. 13, pp. 4584, 2021.

CONFERENCES

1. **Y. Kim**, C. Kim, B. Lee, Y. Jeong, and B. Lee, “Meta-optic Miniaturized Telephoto Lens System,” High Contrast Metastructures XII, SPIE Photonics West 2023, San Francisco, USA, paper 12432-32, Feb. 2023. **(Oral presentation)**
2. **Y. Kim**, C. Kim, and B. Lee, “Phase contrast imaging with multiwavelength achromatic spiral metalens,” OSA Optical Design and Fabrication Congress, Virtual Conference, paper FW4C.3, Jun. 2021. **(Oral presentation)**
3. **Y. Kim**, J. Hong, and B. Lee, “Edge detection metalens with additional spiral phase profiles,” The 20th International Meeting on Information Display (IMID 2020), Virtual Conference, paper 04-10-1232, Aug. 2020. **(Oral presentation)**
4. **Y. Kim**, C. Kim, and B. Lee, “Single-layer edge detecting metalens with combining hyperbolic and spiral phase profiles,” The 14th Pacific Rim Conference on Lasers and Electro-Optics (CLEO PR 2020), Virtual Conference, paper P5-7, Aug. 2020.
5. **Y. Kim**, J. Hong, J. Sung, and B. Lee, “Transmission-Type Color Filters with Silicon Mie Resonators using Guided-Mode-Resonance,” OSA Frontiers in Optics + Laser Science APS/DLS, Washington D.C., USA, paper JW4A.74, Sep. 2019.

RESEARCH INTEREST

- **Metasurfaces & Nanophotonics for imaging and display systems**
 - Physical understanding of nanostructure’s optical behavior and design using near-field simulation tools (RCWA, FDTD, FEM, etc.)
 - Design of waveguide-type folded metasurface system using ray- and wave-optic simulations
 - Hands-on optical experiments (+5 years)
 - Hands-on nanofabrication using lithography-techniques (+5 years)
 - Applications to cameras, AR/VR displays, holographic displays, microscopy, etc.
- **Computational optics design**
 - End-to-end optimization of metalens imaging system (Hardware + Software co-design)
 - Nanostructure optimization through rigorous coupled-wave analysis using automatic differentiation
 - Joint optimization of metasurface and spatial light modulator (SLM) phase profiles

SKILLS

Numerical simulations

Optical near-field simulations:

RCWA (Python, Pytorch), FEM (COMSOL Multiphysics), FDTD (Lumerical)

Optical far-field simulations:

Ray-optic simulation (Zemax), Wave-optic simulation (MATLAB, Python, Pytorch)

Computational optics design:

Data-driven optimization through machine-learning framework (Pytorch),
Inverse design of periodic nanostructures using automatic-differentiation (Pytorch)

Programming languages & tools:

MATLAB, Python (Pytorch), ZPL (for Zemax)

Experimental

Photography, Holographic display with spatial light modulator, Laser/LED-based

experiences	experiments
Device fabrication	Nanofabrication: Electron beam lithography, Photolithography (Aligner, Maskless lithography), Electron beam evaporation, Plasma-enhanced chemical vapor deposition (PECVD), Reactive ion etching (RIE), Focused ion beam (FIB) milling
Languages	Measurement: Scanning electron microscope (SEM), Ellipsometry Korean (Native) / English (Fluent)

PATENTS

1. Y. Park, [Y. Kim](#), G.-Y. Lee, B. Lee, Y. Jeong, “[Double sided metalens and electronic device including the same](#)” (US – Application No. 18/490,121)
2. Y. Jeong, S.-W. Nam, [Y. Kim](#), D. Kim, “[Holographic display using metasurface and metasurface optimization method](#)” (US – Application No. 18/737,648)
3. J. Hong, C. Kim, B. Lee, [Y. Kim](#), G.-Y. Lee, J. Jang, Y. Jeong, “[Color-routing element, method of manufacturing the same, and image sensor including the color-routing element](#)” (US – Application No. 18/937,958)